



# Research and Development Section Indian Institute of Technology Guwahati Guwahati-781039, Assam

Applications are invited for a **Walk-in interview** for the following post(s) in the project entitled, "**Investigation of Solid Flow in an Elevated Temperature Fluidized Bed with Decomposing and Non-Decomposing Liquid Injection through Side Wall Pneumatic Nozzles**" at the Department of Chemical Engineering, IIT Guwahati.

**Date: 25 January 2024 (Thursday)**

**Time: 10.00 am**

**Venue: Walk-in Interview (Conference Hall-I, Department of Chemical Engg, IIT Guwahati)**

Sl. No.	Designation	Number of Vacancies	Pay Recommended (Rs.)	HRA (Rs.)	Medical (Rs.)	Total Amount (Rs.)	Duration of Appointment in months	Qualifications
1	JRF(GATE)	01	31000	4960	1250	37210.00	11	<b>Essential Qualification</b> B E/B Tech/ M E/M Tech degree in Chemical Engineering/ Chemical Technology /Mechanical Engineering/ Food Technology/ Biochemical Engineering/ Biotechnology  Candidate should have qualified GATE or any other National Level examinations conducted by Central Government Departments and their Agencies and institutions.

**How to apply and selection process:** Candidates have to appear in a Walk-in Interview, which is scheduled on **25 January 2024 (Thursday)** at 9:30 am. Advance copy of CV giving details of all educational qualifications, experience, contact address, phone no., email etc. along with scan copies of relevant documents should be sent on or before 24<sup>th</sup> January 2023 (2 PM) to the Principal Investigator by email with subject line "*Application for JRF Position*". Candidate needs to come for interview with original documents for verification.

Selection will be based on the performance of the candidate in the Walk-in interview. Candidates will not be sent any call letter separately.

For any clarification, contact: Pankaj Tiwari (Principal Investigator)

Email: Pankaj.tiwari@iitg.ac.in

Phone: 0361-258-2263

**No TA/DA will be paid to the candidates for appearing in the interview.**

**xCLESPNBRNS00939xxPT006**

**Assistant Registrar (R&D)**